



IFW

Docket No.: P8375.0002
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Hidemitsu Aoki et al.

Patent No.: 6,890,391

10 680 216

Confirmation No.: 7422

Issued: May 10, 2005

Art Unit: 1746

For: METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE AND
APPARATUS FOR CLEANING
SUBSTRATE

Examiner: B. S. Carrillo

SUBMISSION OF INFORMATION DISCLOSURE STATEMENT (IDS)
AFTER ISSUANCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the cited reference be inserted into the file of the above-captioned patent. We acknowledge that the reference will not be considered, and that the reference will not be of record.

Dated: February 15, 2006

Respectfully submitted,

By Michael J. Scheer
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PTO/SB/08a/b (07-05)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet	1	of	1	Attorney Docket Number	P8375.0002
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Complete if Known

Patent Number	6,890,391
Issue Date	May 10, 2005
First Named Inventor	Hidemitsu Aoki
Application No.	10/680,216
Examiner Name	B. S. Carrillo

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
AA*	US-5,749,159		05-12-1998	Schwenkler	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				

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NON PATENT LITERATURE DOCUMENTS

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Examiner Signature	Date Considered
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